Supplementary Information

Self-Powered Pressure and Light Sensitive Bimodal Sensor based on Long-term Stable Piezo-Photoelectric MAPbI₃ Thin Films

Ji-Ho Eom,¹ Hyung-Jin Choi,¹ S. V. N. Pammi,¹ Tran-Van Dang,¹ Yun-Jeong Kim,² Hye-Jin Kim,²* and Soon-Gil Yoon¹*

¹Department of Materials Science and Engineering, Chungnam National University, Daeduk Science Town, 34134, Daejeon, Republic of Korea

²Multidisciplinary Sensor Research Group, Electronics and Telecommunications Research Institute, 34129, Daejeon, Republic of Korea

*Corresponding author: sgyoon@cnu.ac.kr, nolawara@etri.re.kr
Fig. S1  Schematic structure of electric circuit to remove the triboelectric effect of the piezoelectric sensors.
Supplementary Movie. 1  Movie showing the behavior of pressure by a finger touch.

Supplementary Movie. 2  Movie showing the behavior of pressure by a pen touch.

Supplementary Movie. 3  Movie showing the press on the sensor device.

Supplementary Movie. 4  Movie showing the current signal of a MAPbI$_3$ sensor device measured with a DP55054 oscilloscope connected to an SR570 A-amplifier.